

R&D of scCVD Diamond Beam Loss Monitors for the LHC

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Outline

- **Idea and motivation**
for cryogenic diamond Beam Loss Monitors (BLMs) for the LHC
- **Details of measuring set-up**
for diamond characterization via TCT
- **The Plasma Effect**
for heavy ionizing particles in scCVD diamonds
- **Raw measurements and derived charge-carrier properties**
for scCVD diamonds
- **Conclusion**



Idea and Motivation

- Place BLMs as close to the beam as possible
 - Detector operation at 1.9 K, within the cold mass
- Choose detector material
 - Candidates are: CVD diamond, silicon, liquid He
- Diamonds not tested yet at ultra-cold temperatures
 - Interesting!
- Characterize scCVD diamonds at cryogenic temperatures with gaseous He cooling
 - Start at RT, decrease stepwise down to 67 Kwith liquid He cooling
 - Start at 1.9 K, increase slowly to 60 K

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DONE!

First test this week!

Pros:

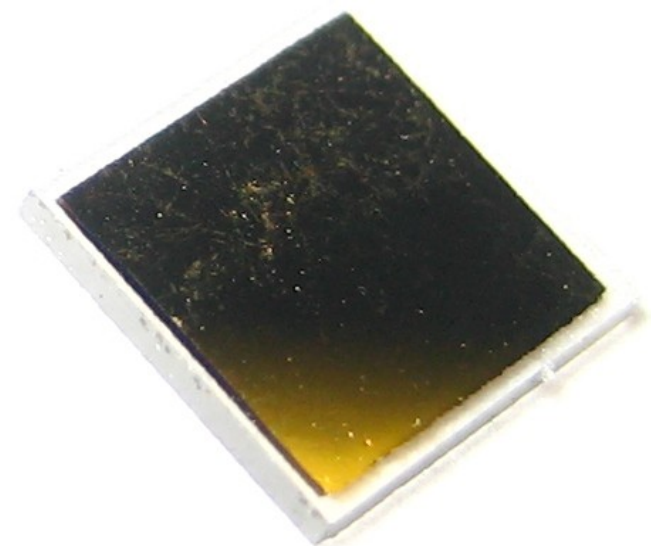
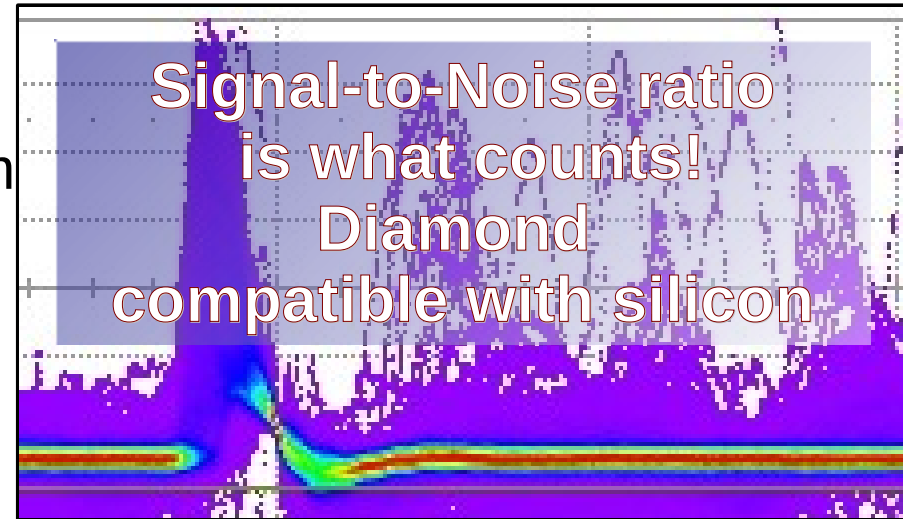


- High band gap (5.5 eV)
 - Very high breakdown field $> 1e7$ V/cm
 - Very high resistivity $> 1e11$ Ω cm
 - Very low leakage current $\lesssim 1$ pA
- Low dielectric constant (5.7)
 - Low capacitance
 - Low noise
- High displacement energy (43 eV/atom)
 - Radiation hard

Cons:



- High pair creation energy (13.5 eV)
 - Less signal (but less noise!)



- The **Transient-Current Technique (TCT)** measurement:

- measure the **transient current**

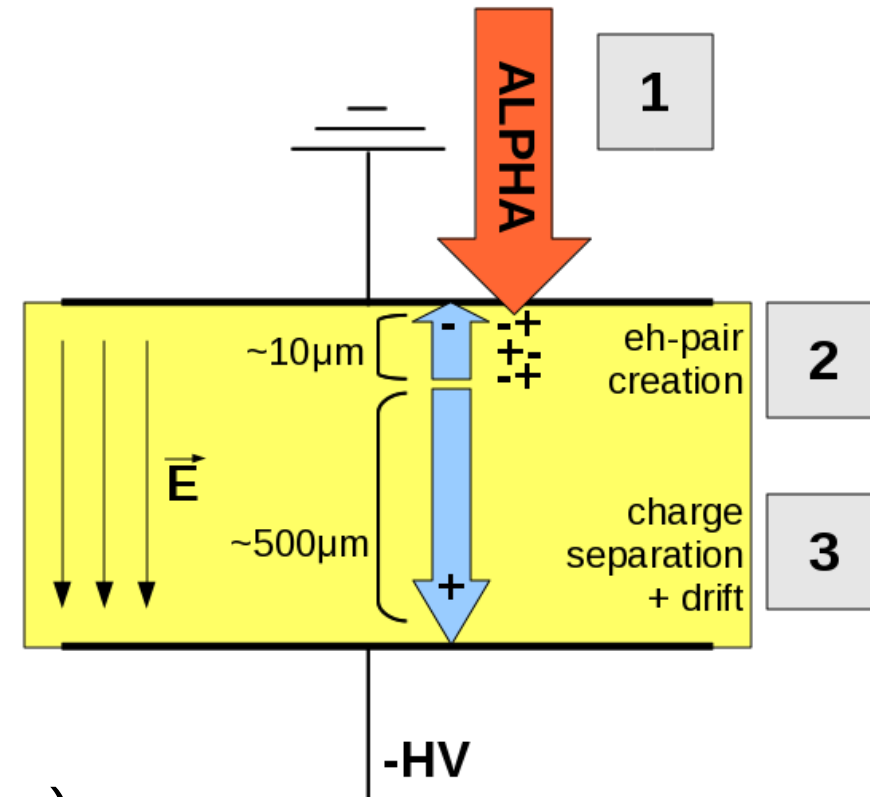
- 1) α particles impinge on top side
- 2) Create eh-pairs **close** to electrode
- 3) Electric field separates charges
- 4) Drifting charges induce current

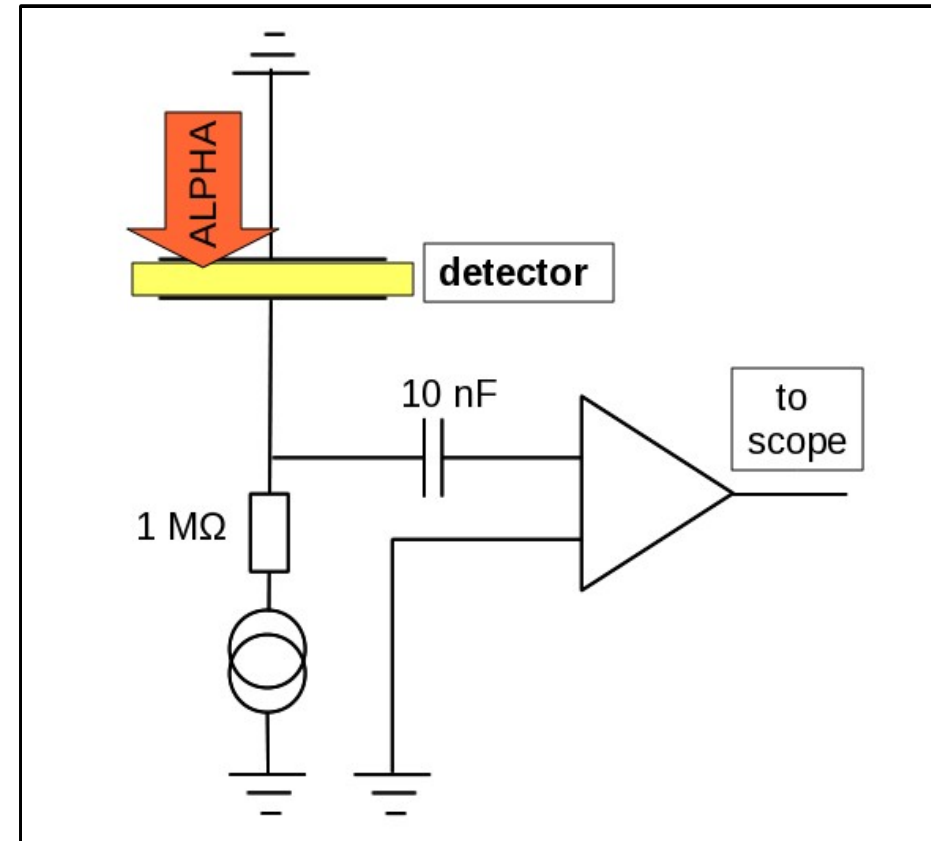
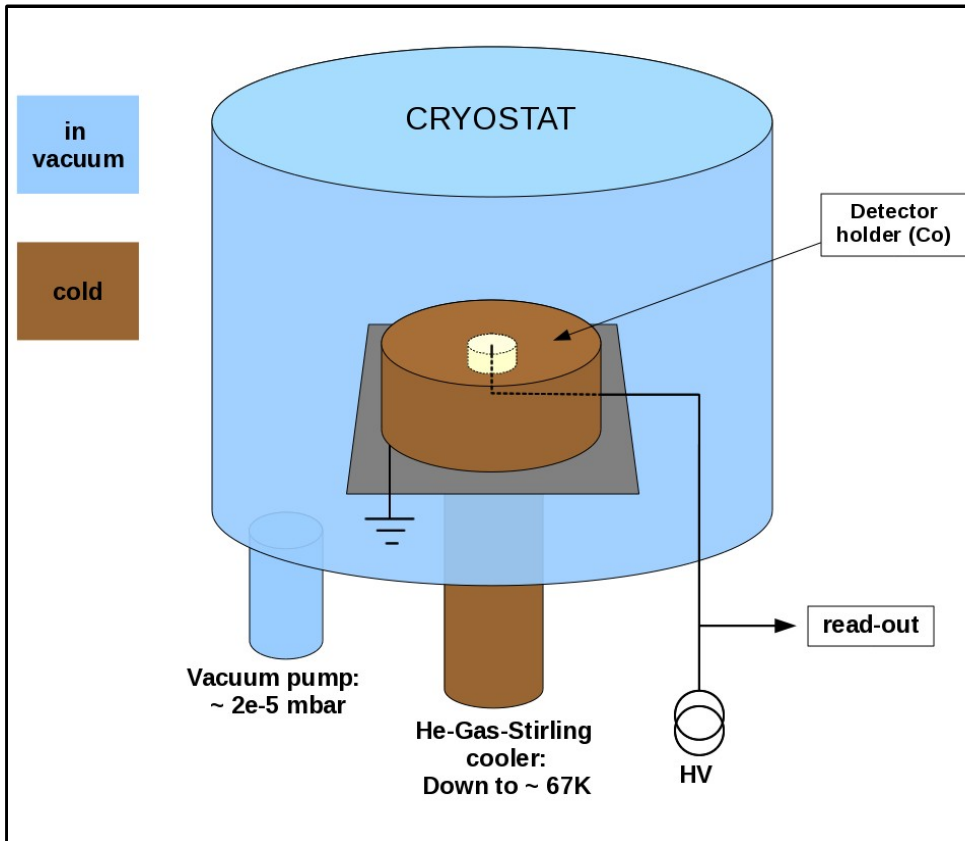
- **Pos.** (**neg.**) bias → Measure e^- (h^+)

- Use ultra-fast 2 GHz, 40 dB, 200 ps rise time current amplifier (cividec)

- Use broad-band 3 GHz scope (LeCroy)

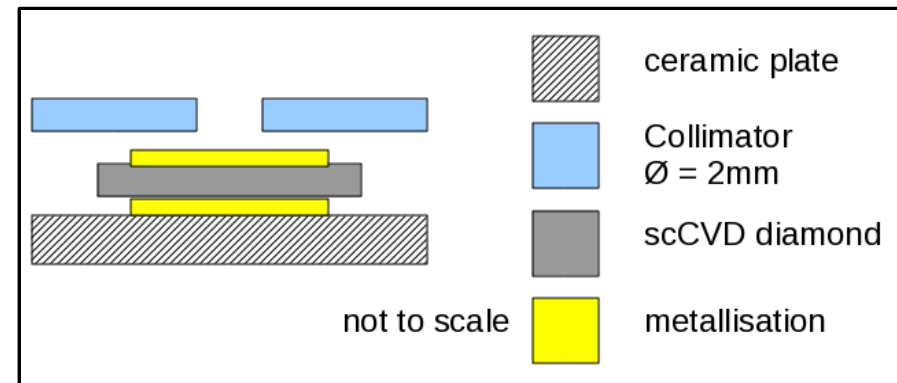
- Use RF components

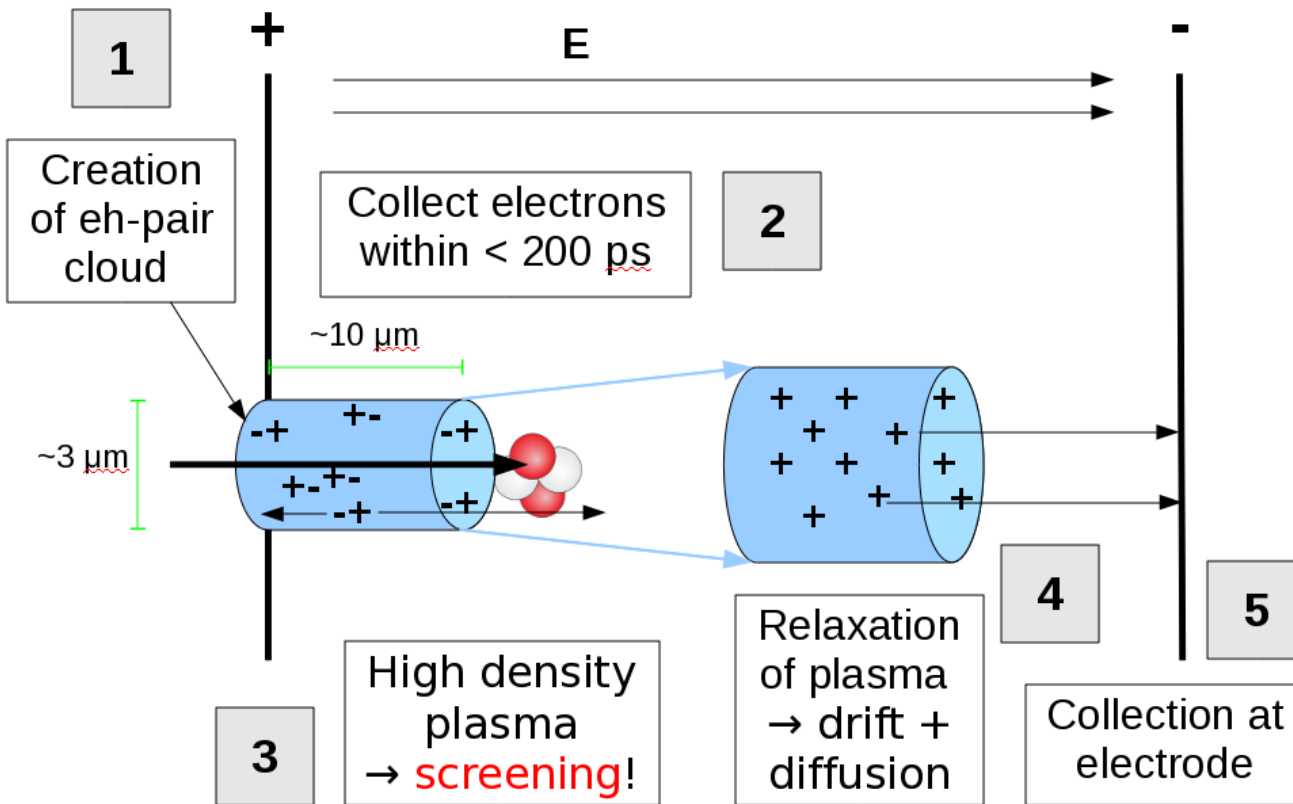




SETTINGS:

- TCT in **vacuum**
- Temp: **67 K - 300 K**, bias ≤ 600 V
- Read-out from **HV-side**
- Use **collimator** (avoid edge-effects)





From Ramo-Theorem:

$$\begin{aligned}
 i(t) &= \sum_k i_k(t) \\
 &= \sum_k e E_w v_k(t) \\
 &= \frac{e}{d} \sum_k v_k(t - t_k^{start}); \\
 v_k(t) &= 0 \text{ for } t < 0
 \end{aligned}$$

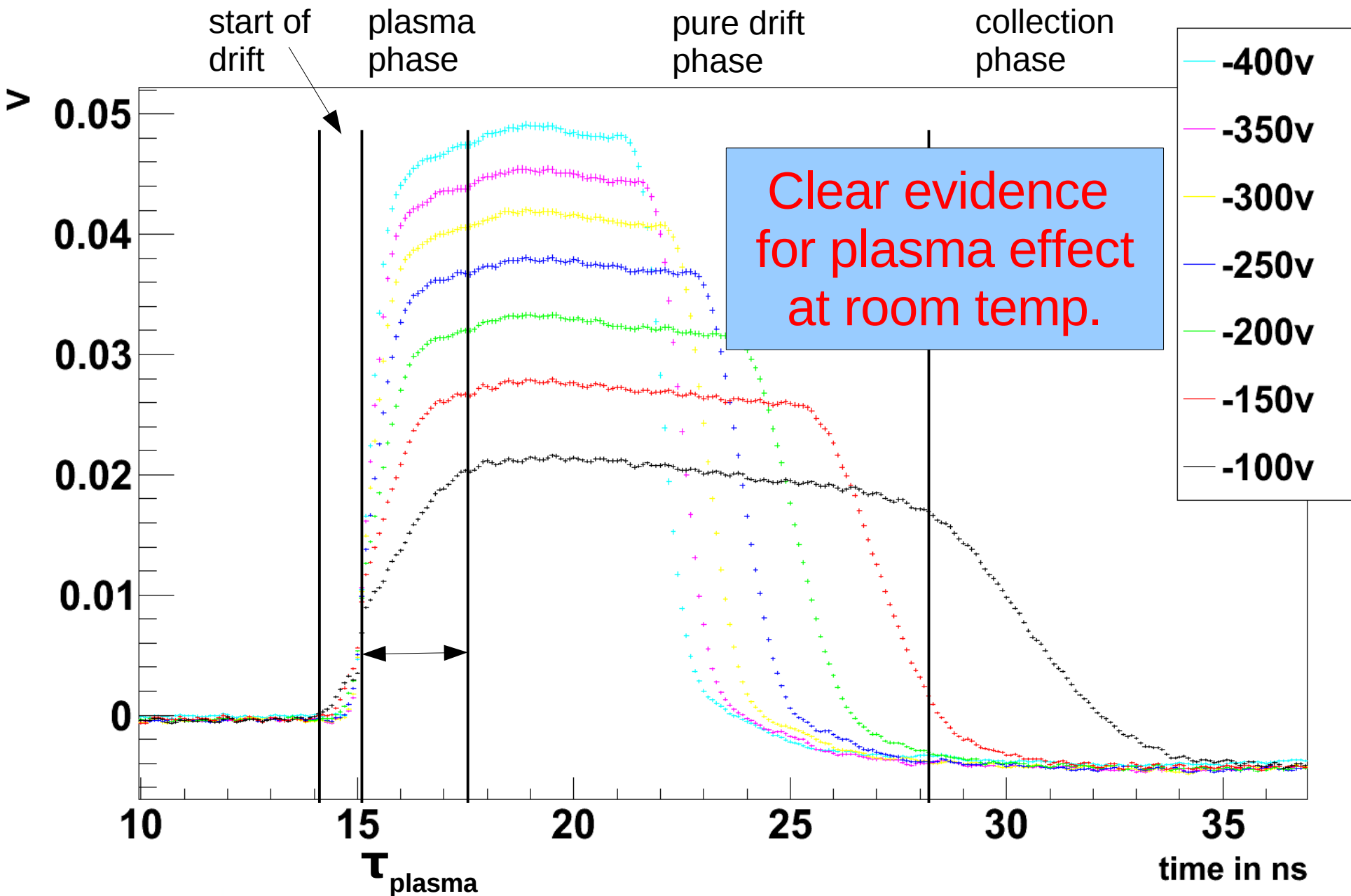
• **FACTS:**

- α s produce **high density** charge cloud
- Outer charges **screen** inner ones
 - E-Field **decreases** inside the plasma
- Increased E-Field decreases lifetime of plasma

$$\rho_{cloud} \approx \frac{3 \cdot 10^5 \text{ pairs}}{(3 \mu m)^2 \pi 10 \mu m} \approx 10^{15} \text{ cm}^{-3}$$



Plasma Effect at 295 K

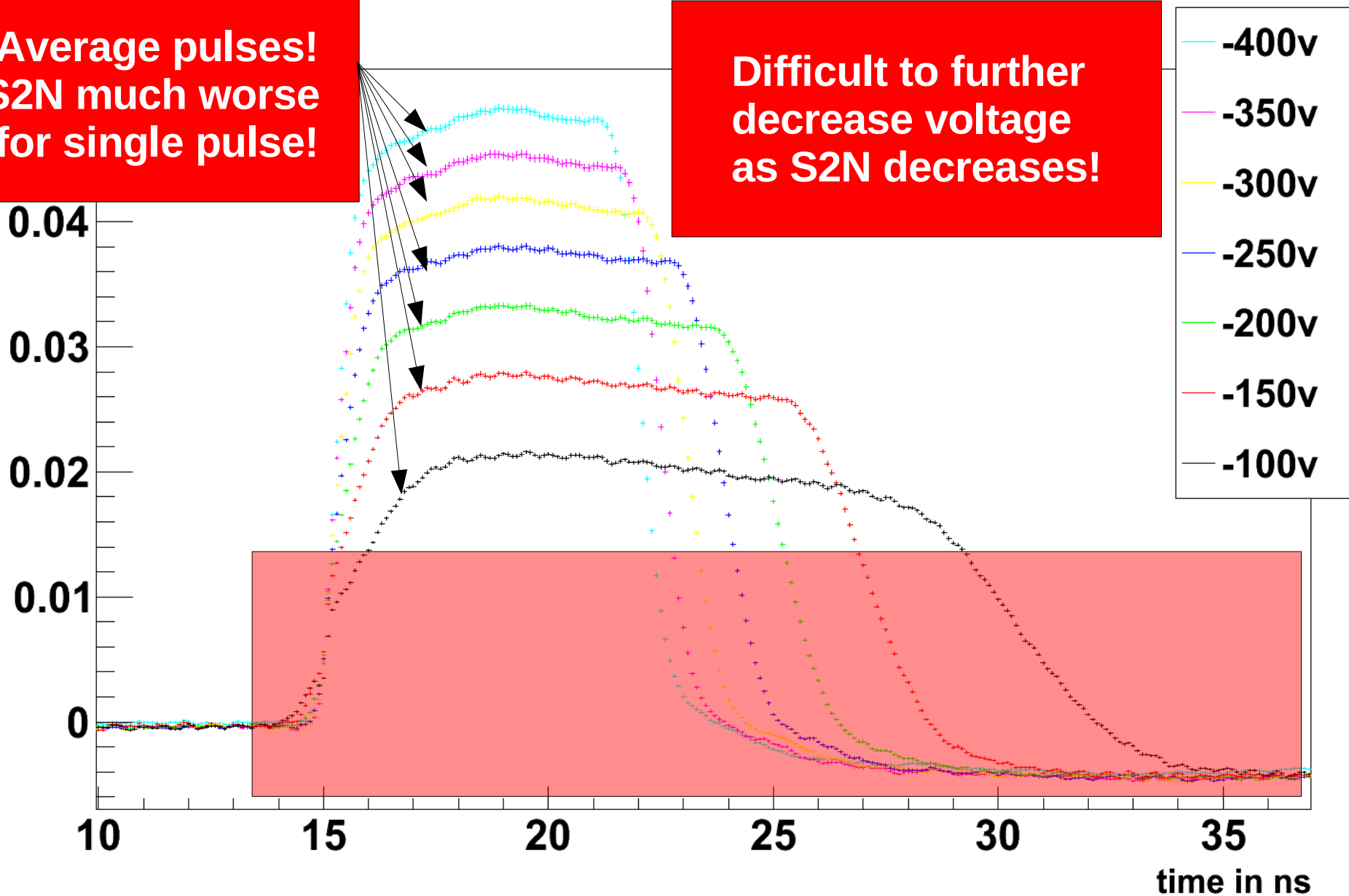




Difficulties

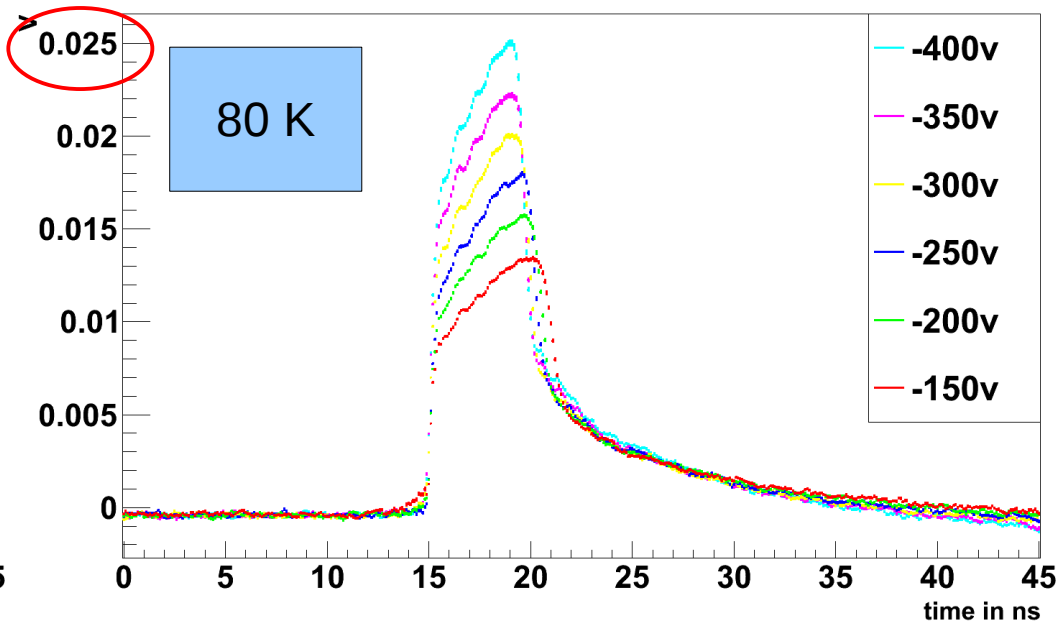
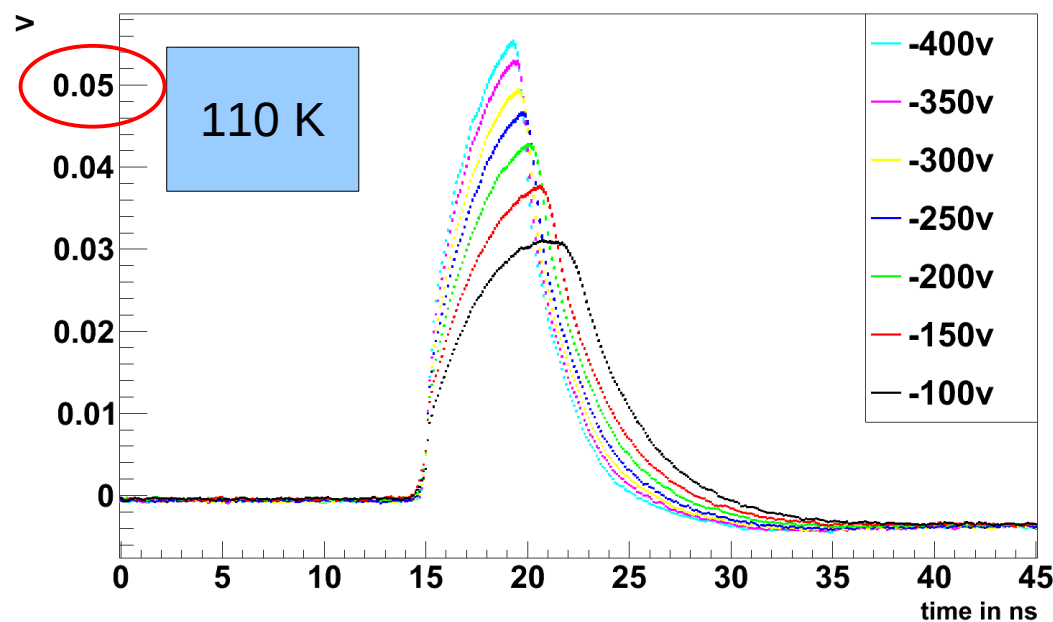
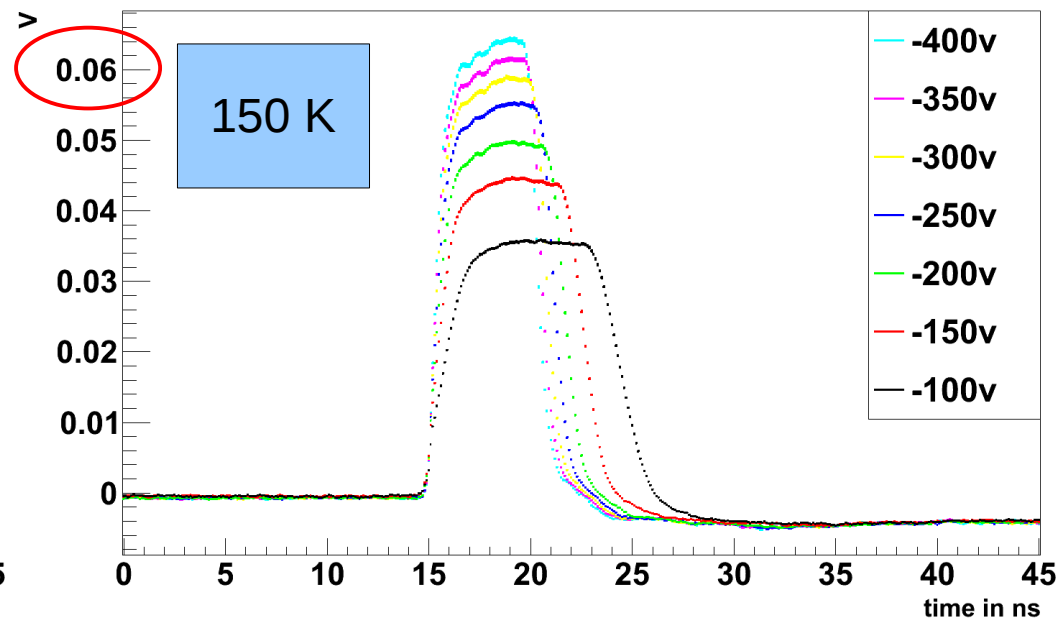
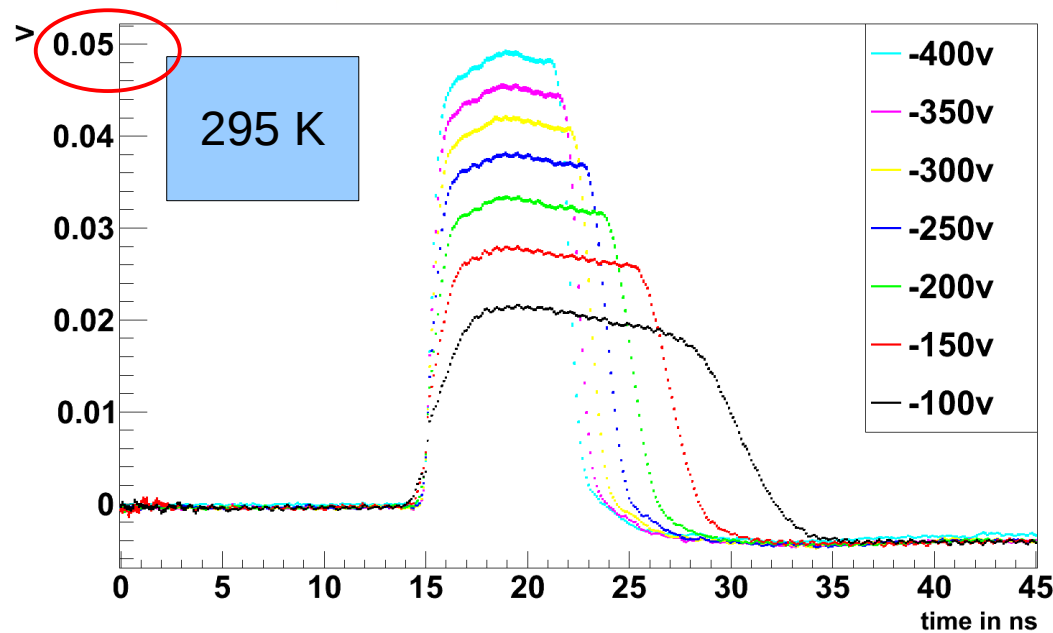
Average pulses!
S2N much worse
for single pulse!

Difficult to further
decrease voltage
as S2N decreases!



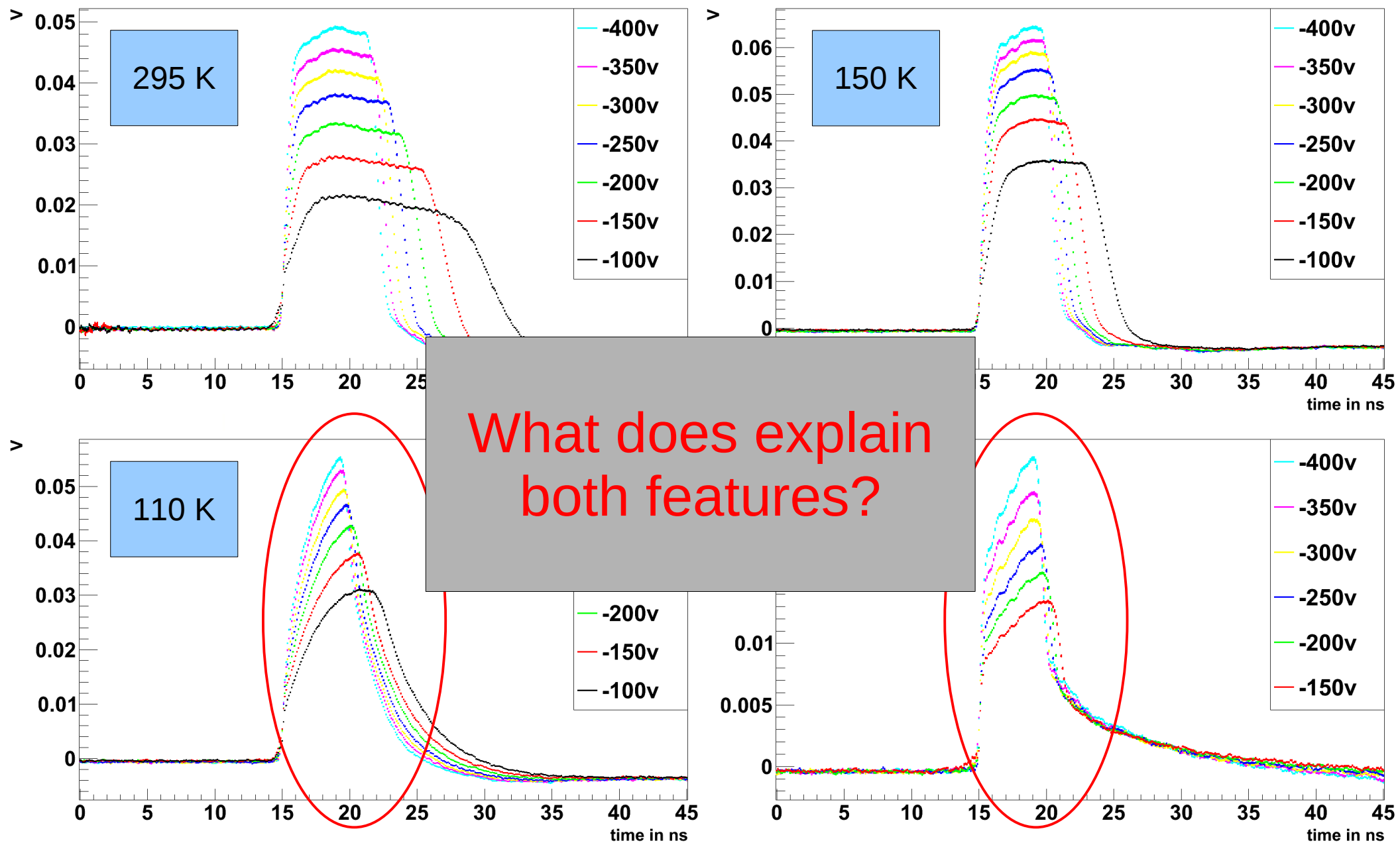


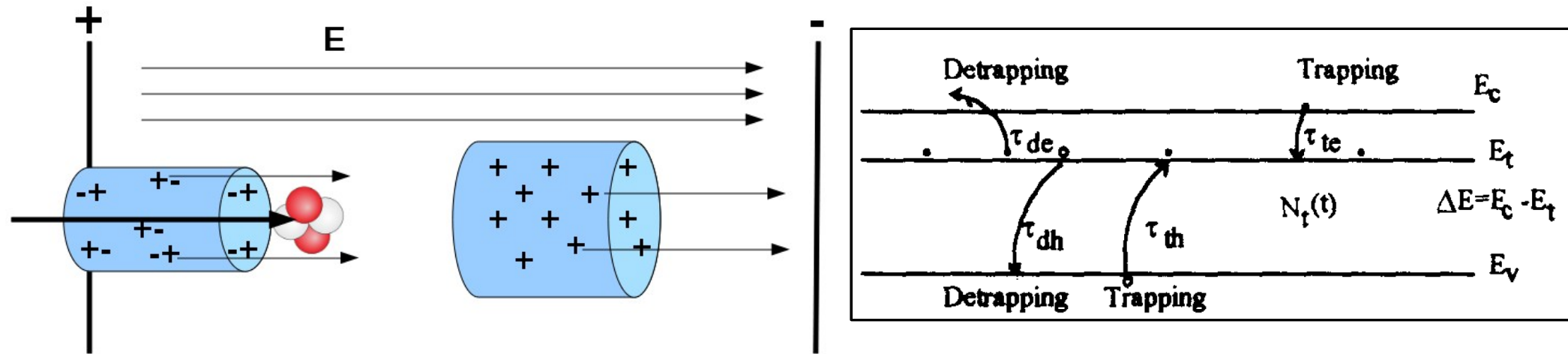
TCT Hole Pulses





TCT Hole Pulses





Below ~150 K:

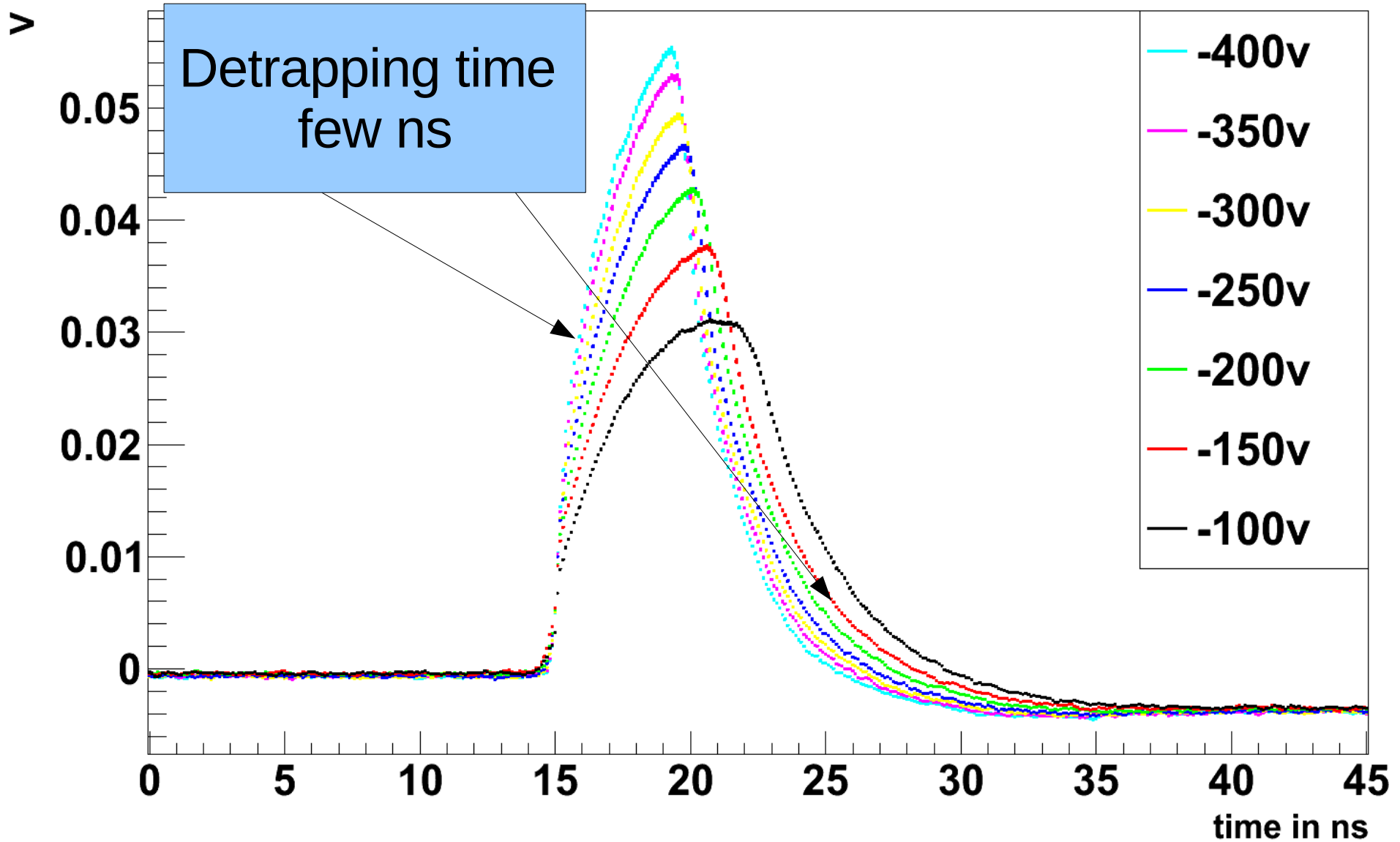
- Field-free region within plasma cloud
→ immediate trapping and increased recombination
- Detrapping if E_{trap} / kT large enough
- Distinguish 2 types of trapping!

$$\tau_{\text{trap}}^{\text{plasma}} \ll \tau_{\text{trap}}^{\text{drift}}$$

From Ramo-Theorem:

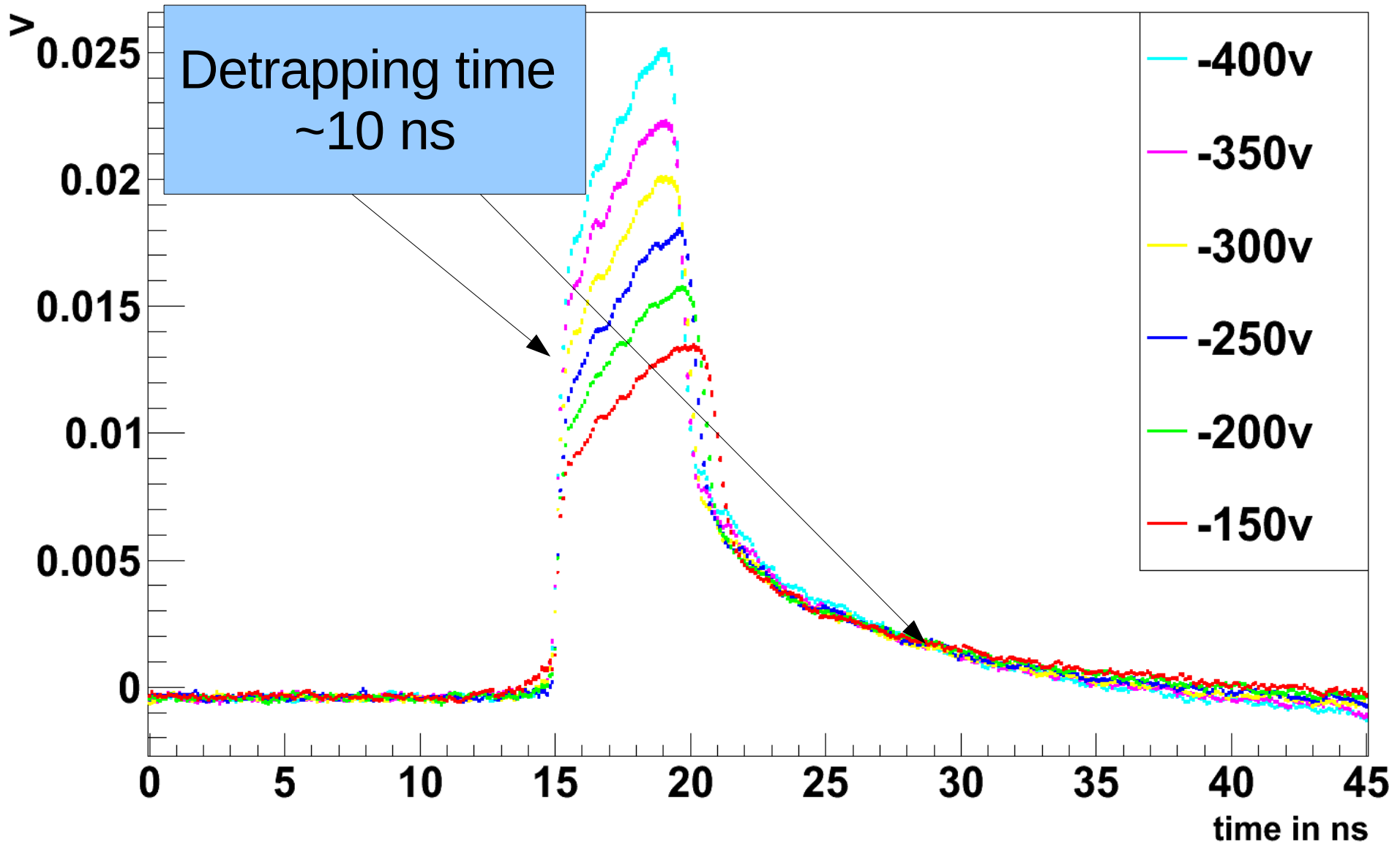
$$\begin{aligned} i_{(t)} &= i_{\text{not-trapped}}(t) + i_{\text{released}}(t) \\ &= \frac{e}{d} \sum_{i, \text{not-trapped}} v_i(t - t_i^{\text{start}}) \\ &\quad + \frac{e}{d} \sum_{i, \text{released}} v_i(t - t_i^{\text{detrap}}); \end{aligned}$$

$$\begin{aligned} Q_{\text{released}}(t) &= \\ Q_{\text{trapped}}(1 - \exp(-t/\tau_{\text{detrap}})); \end{aligned}$$



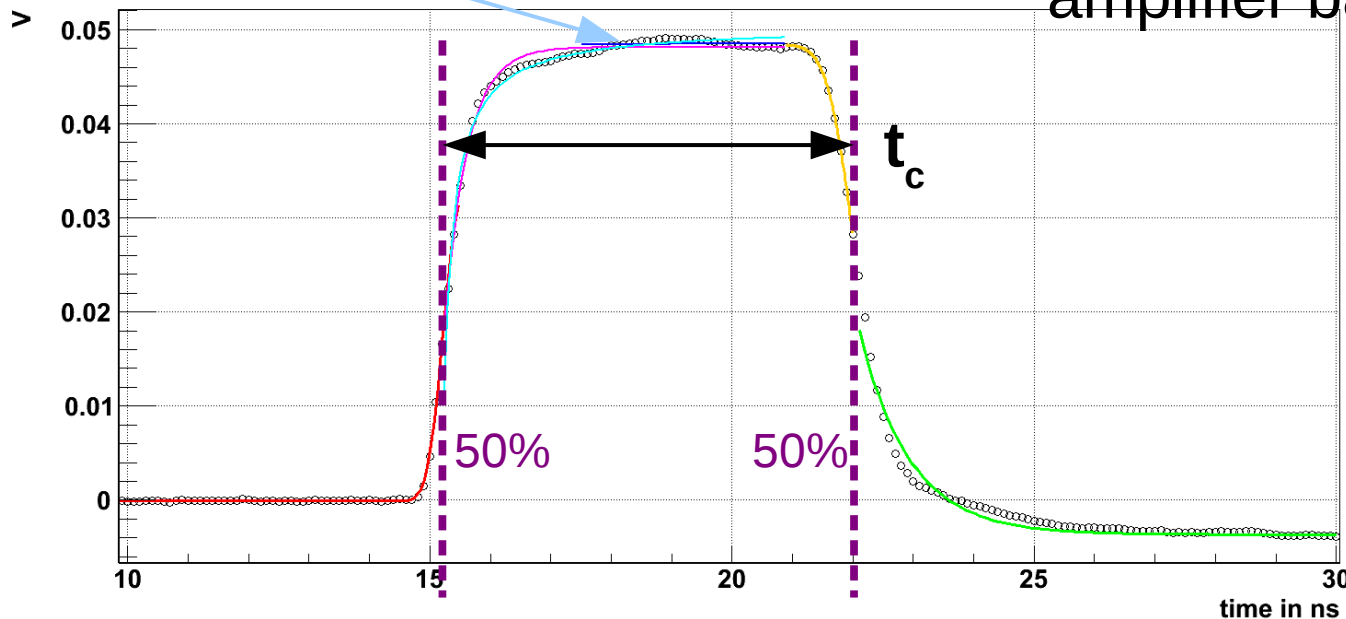
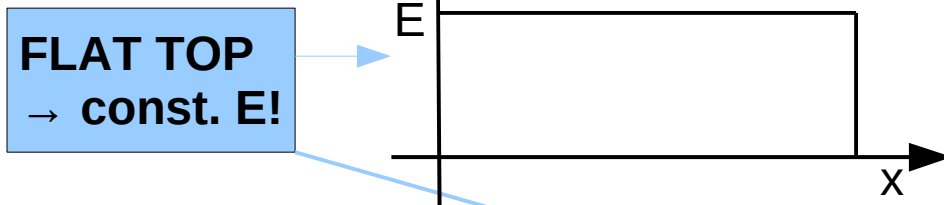


Trapping/Detrapping at 80 K

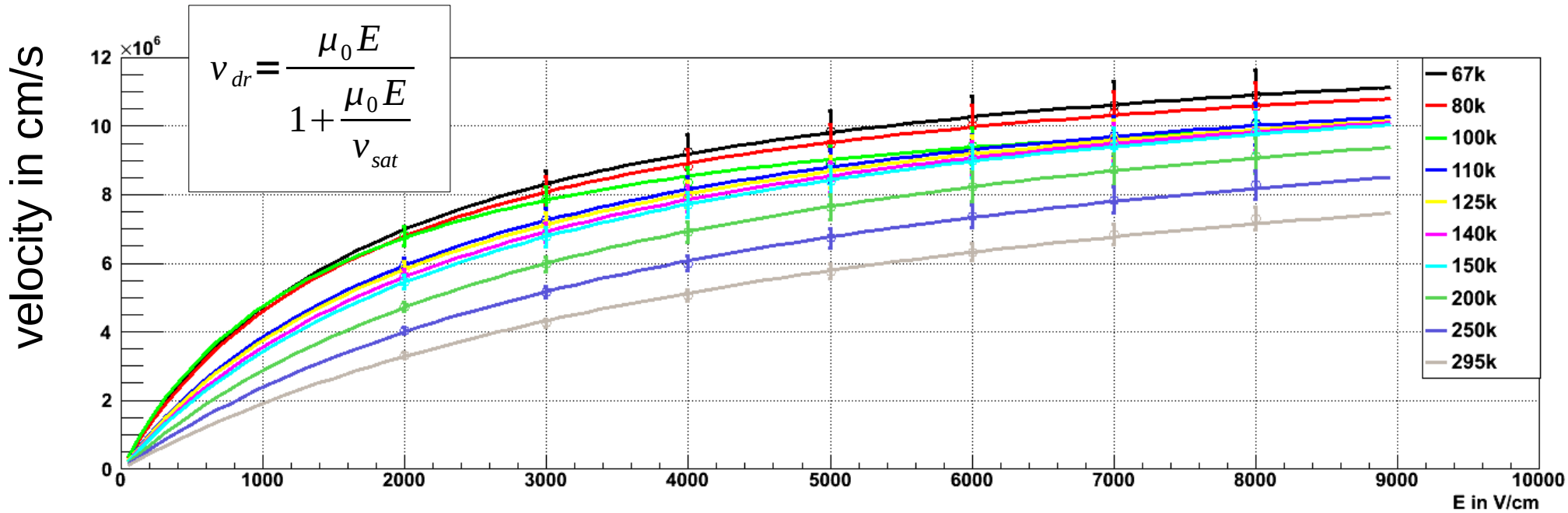


- Four phases:

- 1) Start of drift
- 2) Current saturation
- 3) Collection at electrode
- 4) Tail



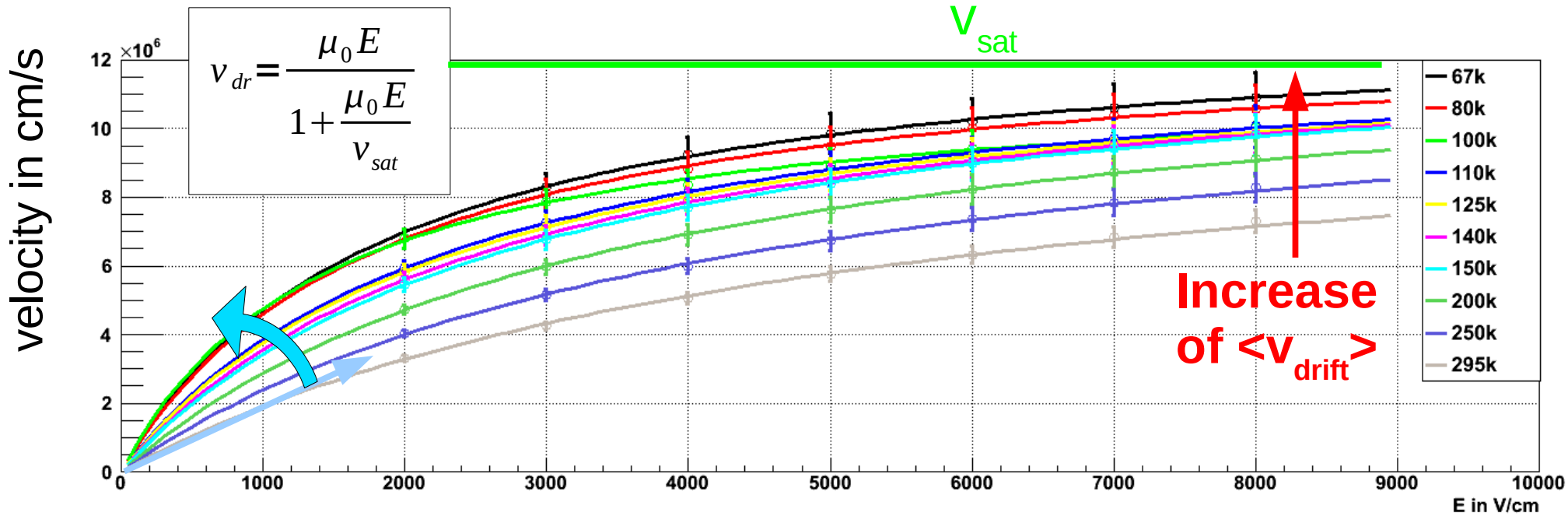
- Fit $\text{Erfc}(t)$ to rising/falling edge:
 - 50% levels mark start/end time
 - Derive drift mobility and velocity
- Fit $1 - \exp(-t/\tau_p)$ to saturation:
 - τ_p is plasma lifetime
- Fit $\exp(-t/\tau)$ to tail:
 - Tail formed by cable effects, amplifier bandwidth limits, diffusion



Fits yield:

$\mu_{0,h}^{295K} = 2278 \pm 110 \text{ cm}^2/\text{Vs}$	$\mu_{0,h}^{67K} = 7300 \pm 1850 \text{ cm}^2/\text{Vs}$
$v_{sat}^{295K} = 11.8 \cdot 10^6 \pm 0.8 \cdot 10^6 \text{ cm/s}$	$v_{sat}^{67K} = 13.4 \cdot 10^6 \pm 1.4 \cdot 10^6 \text{ cm/s}$

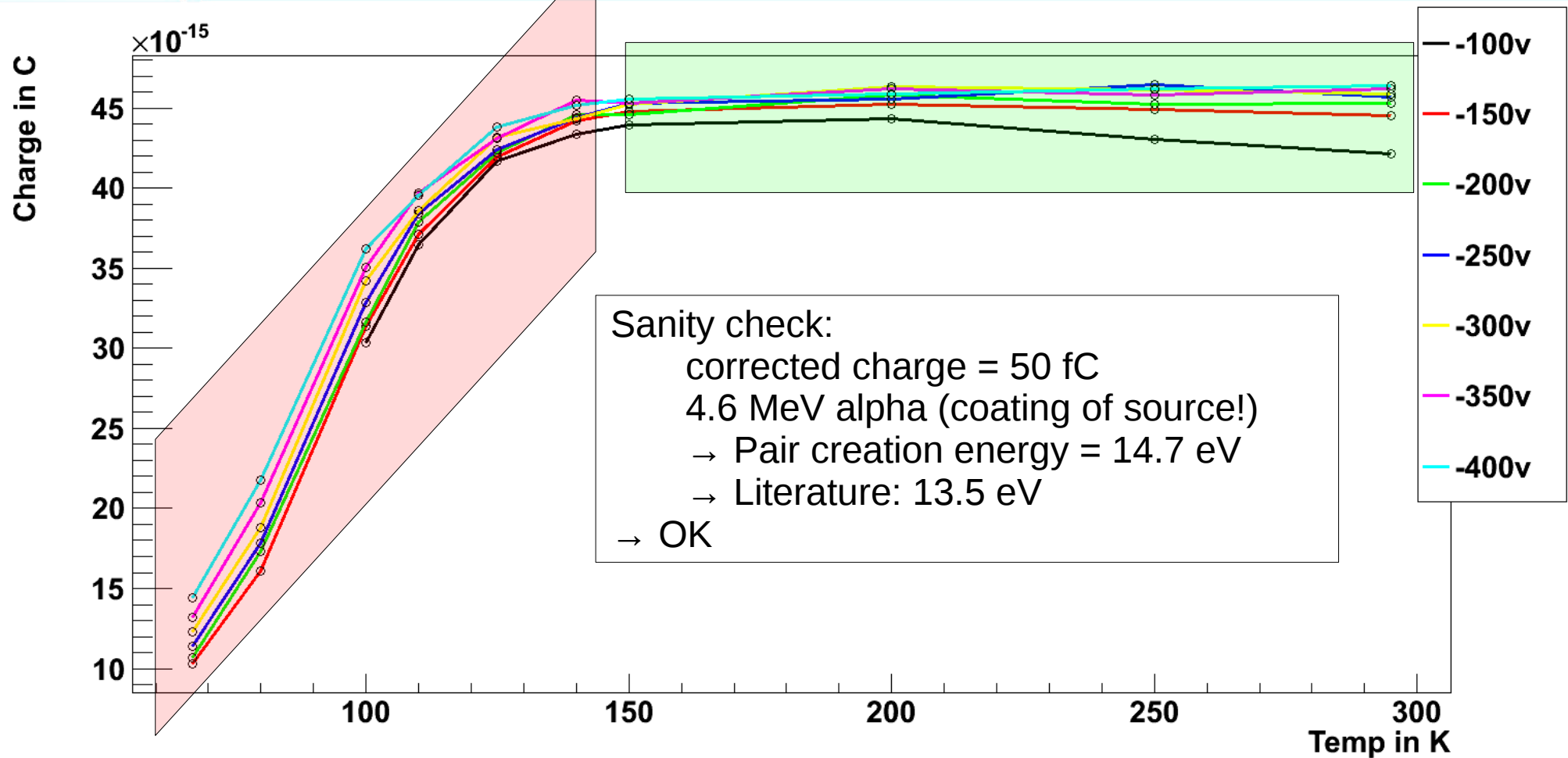
- Mobility μ_h and avg. drift velocity $\langle v_{drift} \rangle$ at RT as expected
- μ_h increases down to 67 K ($\rightarrow \langle v_{drift} \rangle$ increases as well)
 \rightarrow no onset of impurity scattering
- $v_{sat} \sim$ constant with temperature



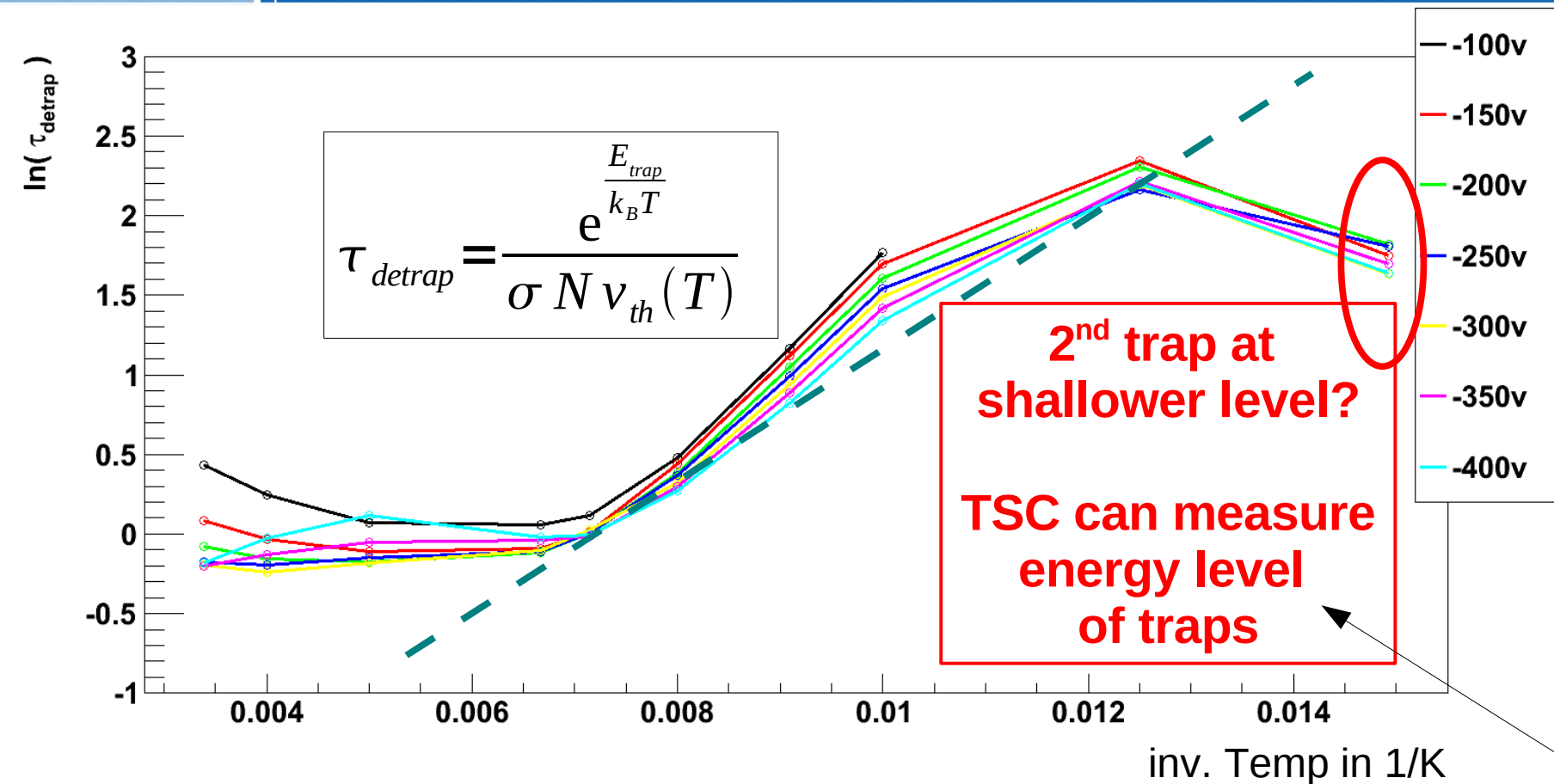
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- Charge constant in range 140 K to 300 K
- Steep drop from 140K down to 67 K
 → plasma associated trapping and recombination



• Plot $\ln(\tau_{dt})$ vs $1/T$, do line fit:

$$E_{trap}^h \approx 40 \text{ meV} \pm 10 \text{ meV}$$

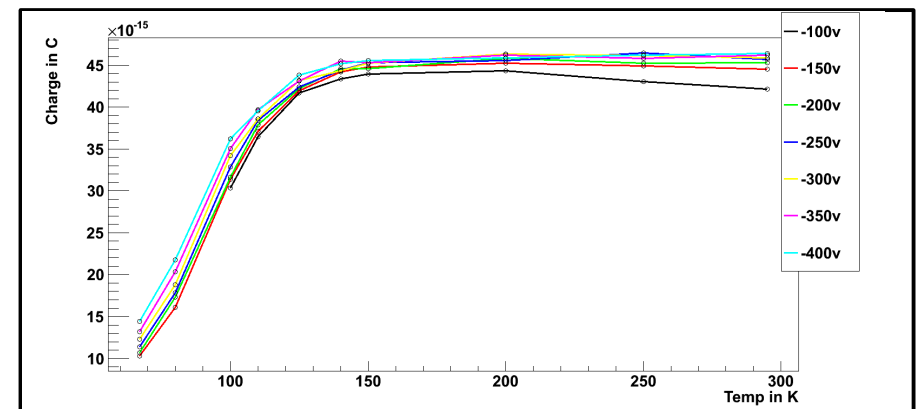
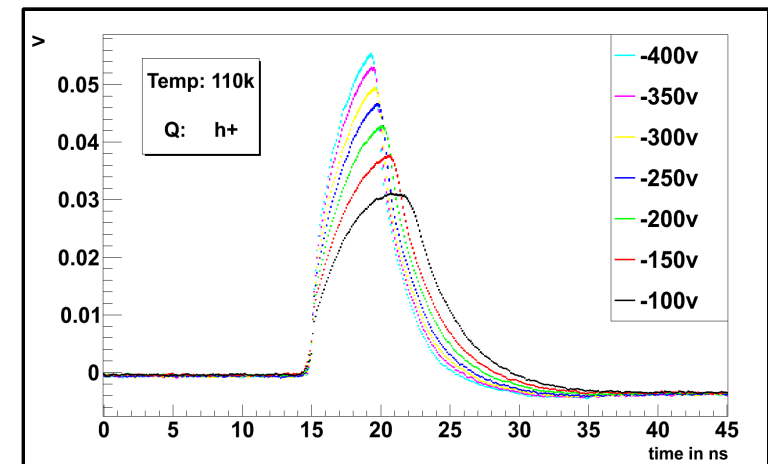
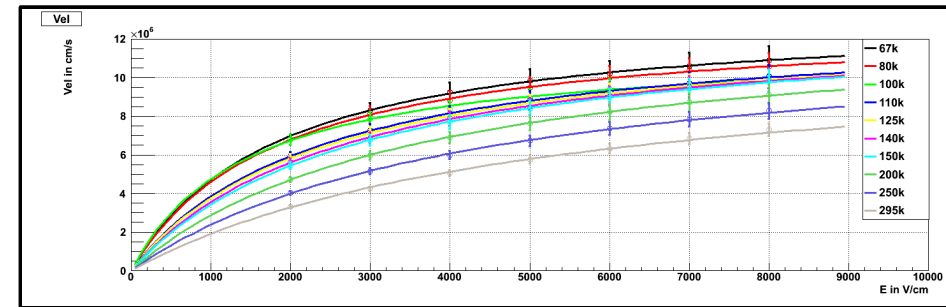
→ lowest shallow trap

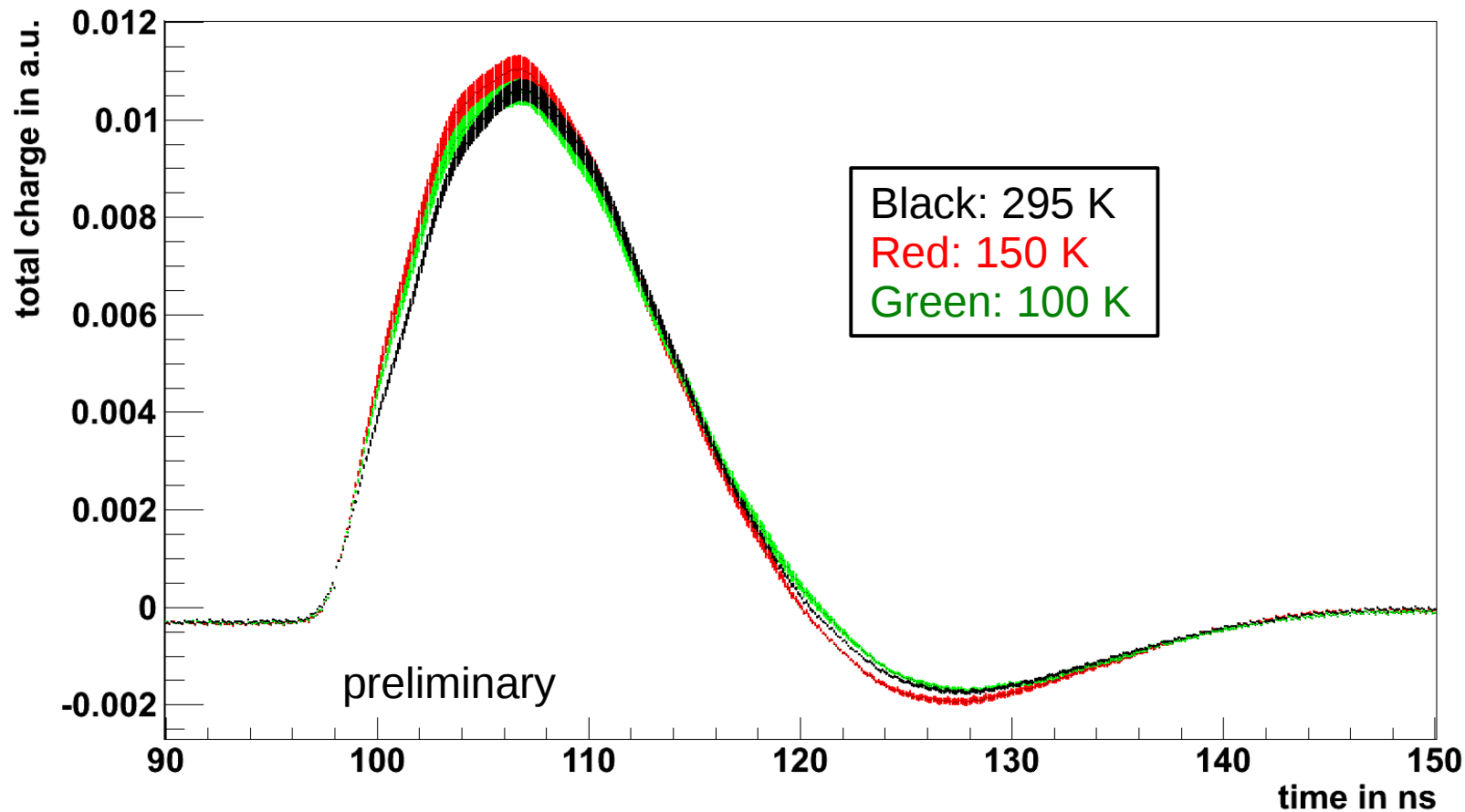
→ investigate further energy levels of traps via Thermally Stimulated Current technique

In contact with
Uni Hamburg

- TCT offers eminent possibility to characterize detectors
- Temperature dependence of
 - drift mobility and velocity
 - total charge
 - trapping-detrapping mechanism
 - pulse shape in scCVD diamonds
- Plasma associated trapping reduces total charge yield at $T < 150$ K

→ $Q_{\text{signal}} \rightarrow 0$ for $T \rightarrow 1.9$ K ??





- Use **charge-sensitive amplifier** here
- No sign of charge degradation (20% with α s at 100K)
- Work in progress!

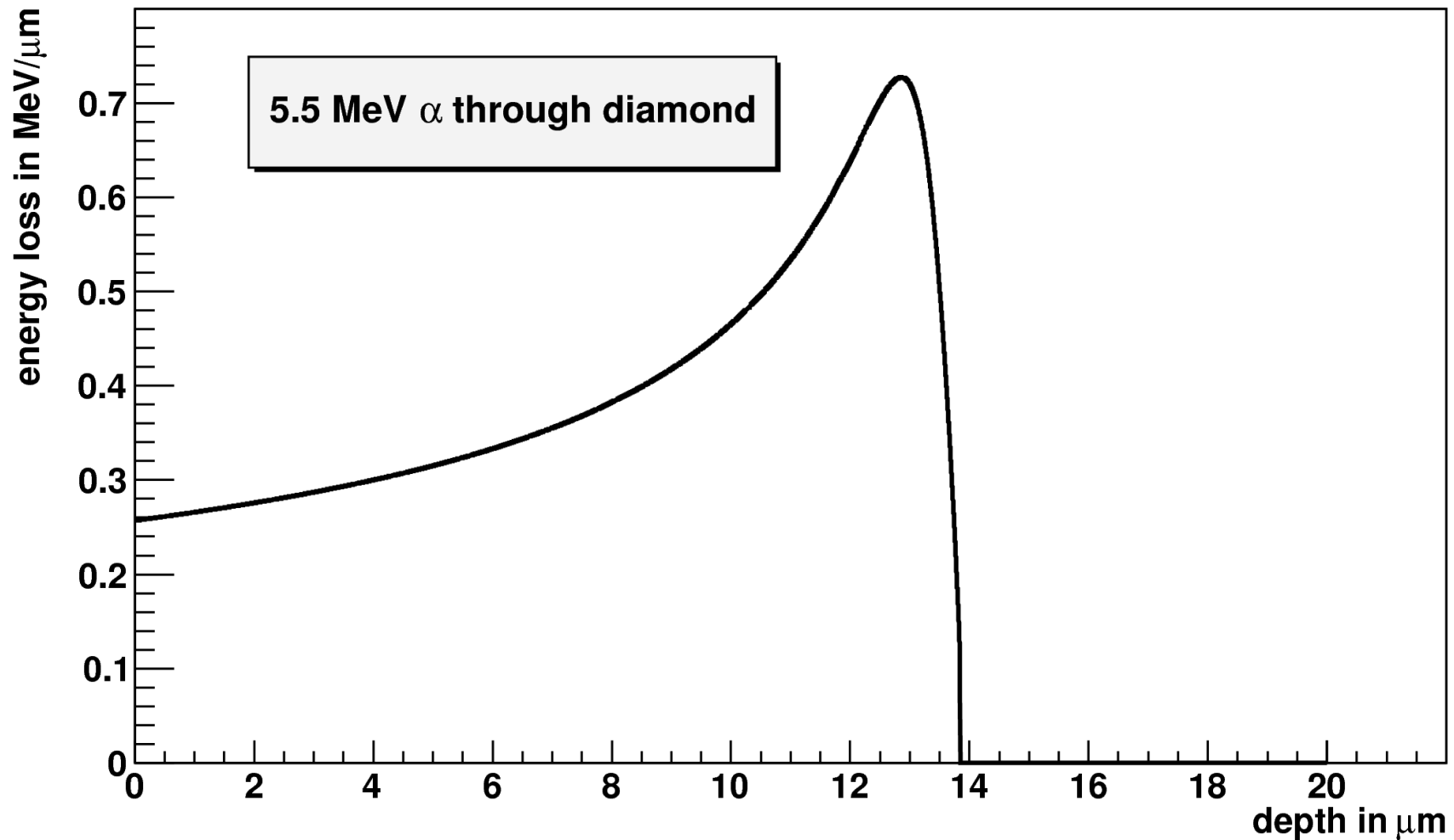


- Paper in preparation
- Simulate pulse shapes
including plasma effect and trapping-detrapping mechanism
- TCT with β -source (this summer)
 - test MIP-like signal with diamond
 - density of charge cloud much smaller
 - no (little) plasma effect expected
- Beam tests at 1.9 K
- TCT with irradiated samples
 - compare scCVD diamond with Si detectors
 - expect better performance for scCVDs!



BACKUP SLIDES

Bragg curve simulator

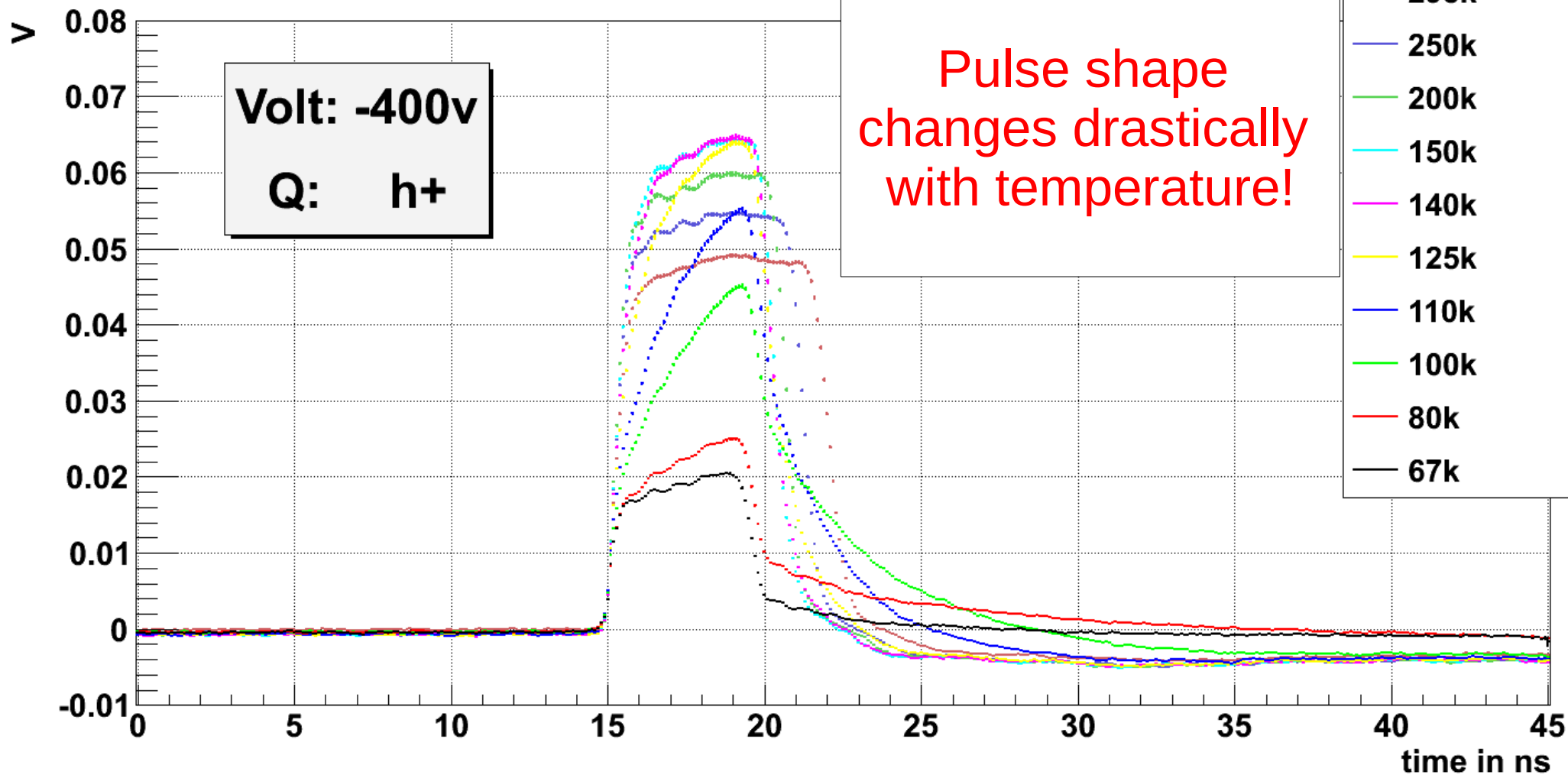


<http://www.nist.gov/pml/data/star/index.cfm>



Pulse Shape for Constant Voltage

avgpulses





Two Contributions to Signal

from Ramo-Theorem:

$$\begin{aligned} i_{(t)} &= i_{non-trapped}(t) + i_{released}(t) \\ &= \frac{e}{d} \sum_{i, not-trapped} v_i(t - t_i^{start}) \\ &+ \frac{e}{d} \sum_{i, released} v_i(t - t_i^{detrap}); \end{aligned}$$

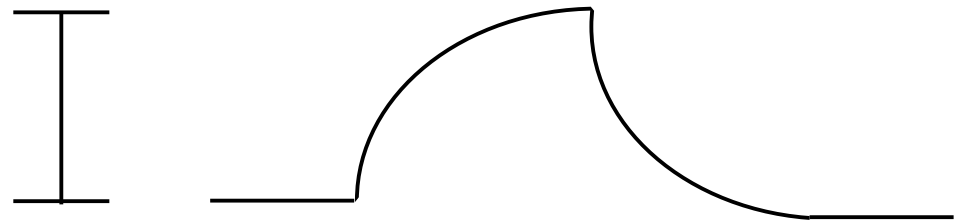
$$Q_{released}(t) = Q_{trapped}(1 - \exp(-t/\tau_{detrap}));$$

non-trapped



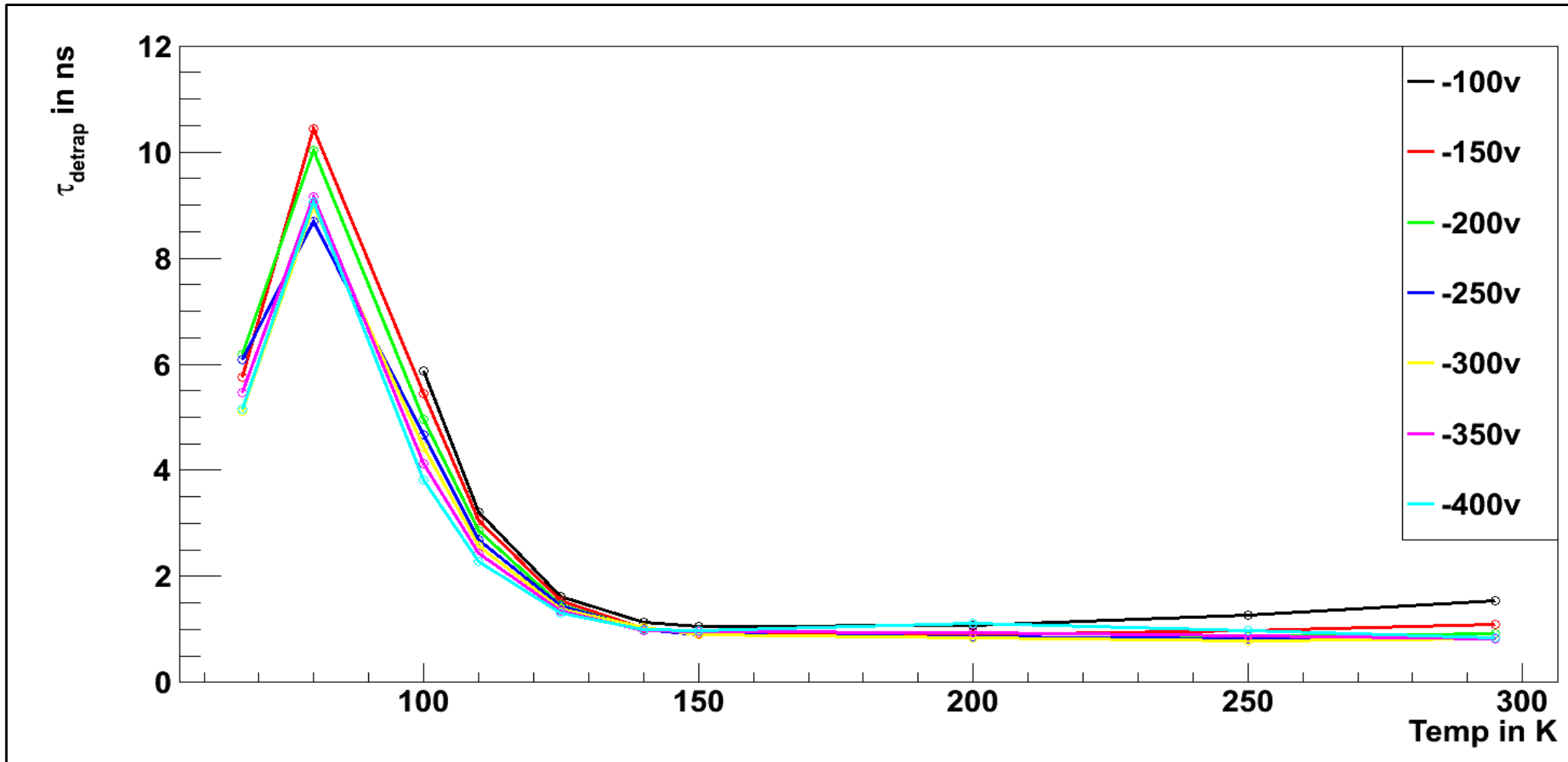
$$Q_{not-trapped} = Q_{\alpha-induced} - Q_{trapped}$$

released



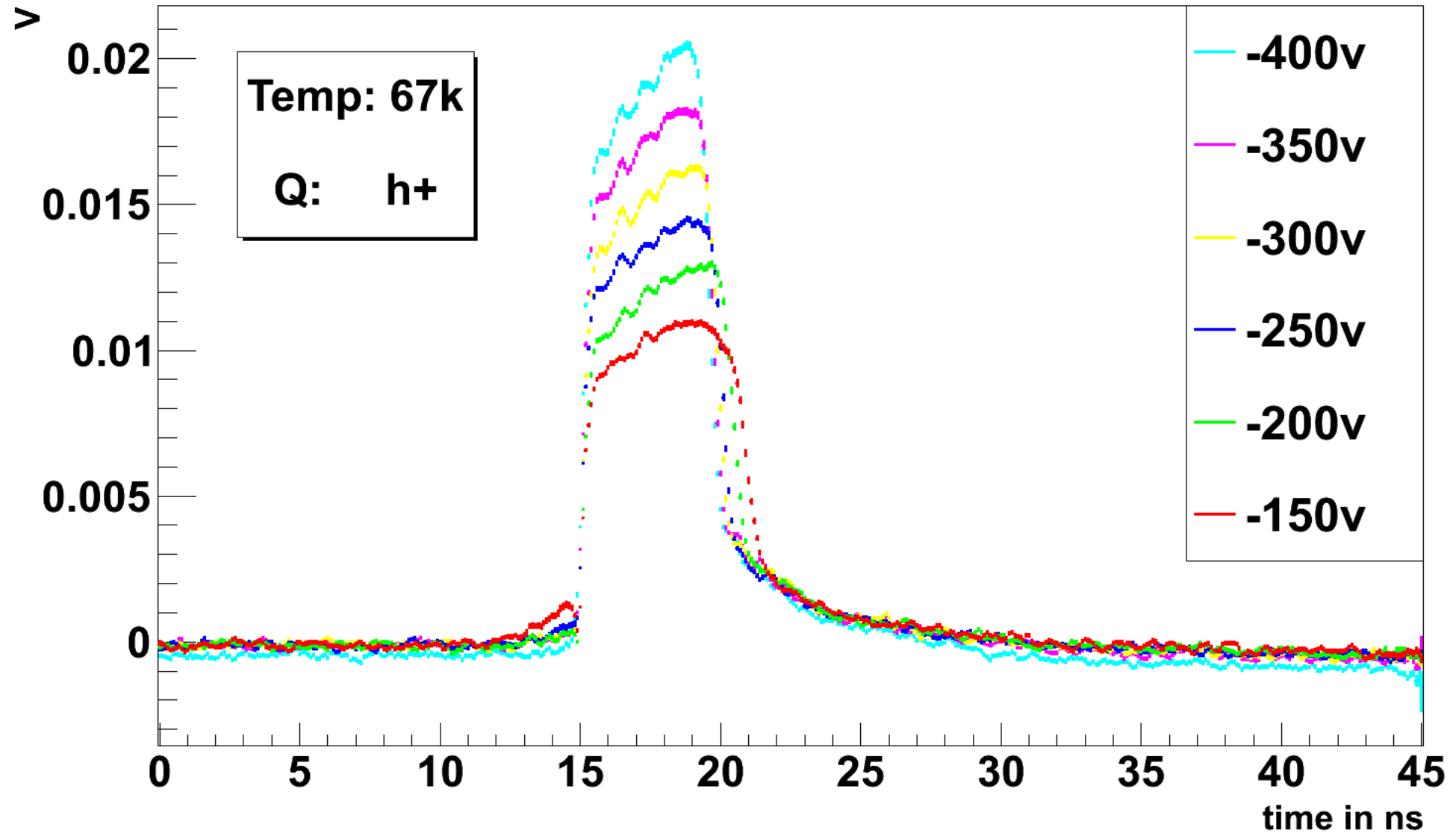


Detrapping vs. T



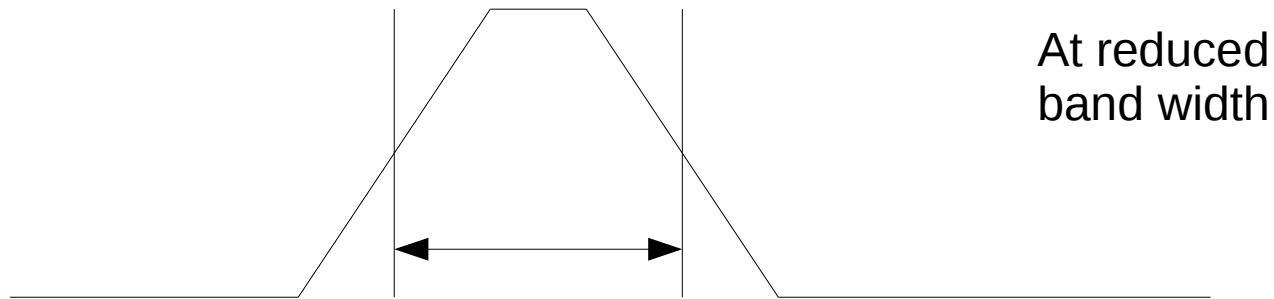
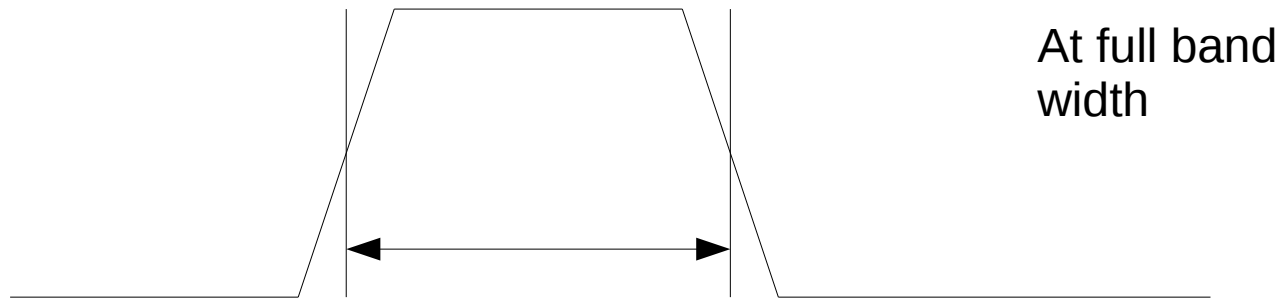


Pulse shape at 67 K





Band width



Reduced band width fakes shorter transient time

